INTERNATIONAL GEMOLOGICAL INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

October 31, 2025

IGI Report Number	LG744504263
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	RECTANGULAR CUSHION MIXED CUT
Measurements	11.00 X 7.39 X 4.77 MM

GRADING RESULTS

Carat Weight	3.60 CARATS
Color Grade	F
Clarity Grade	VS 1

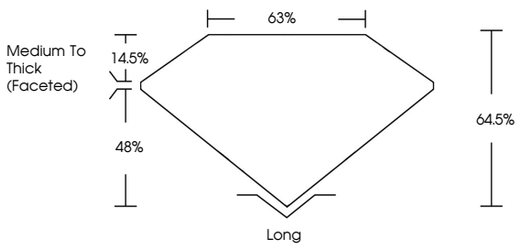
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG744504263

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG744504263
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

© IGI 2020, International Gemological Institute

FD - 10 20

THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

www.igi.org

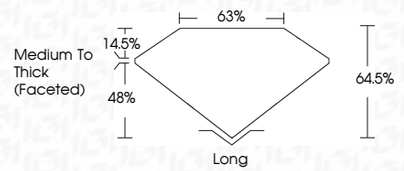
LABORATORY GROWN DIAMOND REPORT

October 31, 2025

IGI Report Number	LG744504263
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	RECTANGULAR CUSHION MIXED CUT
Measurements	11.00 X 7.39 X 4.77 MM

GRADING RESULTS

Carat Weight	3.60 CARATS
Color Grade	F
Clarity Grade	VS 1



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG744504263

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI

October 31, 2025
IGI Report No LG744504263
RECTANGULAR CUSHION MIXED CUT
11.00 X 7.39 X 4.77 MM
Carat Weight 3.60 CARATS
Color Grade F
Clarity Grade VS 1
Depth 64.5%
Table 63%
Girdle Medium To Thick (Faceted)
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) IGI LG744504263
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa